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Application Number	09/874,766
Filing Date	June 5, 2001
First Named Inventor	Reza Alani
Group Art Unit	2878
Examiner Name	

(use as many sheets as necessary)

Sheet	1	of	2	Attorney Docket Number	GAT 0074 PA
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Examiner
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Date
Considered

6/26/07

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 2 of 2

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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Urf		LANGER, Elektronenoptische Untersuchung des Werkstoffverhaltens in mechanisch belasteten Mikrobauteilen, 13.12.1996, pgs. 56-60	
		S. SENZ et al., Optimisation of the wire-shadow TEM cross-section preparation technique, Ultramicroscopy 70 (1997) 23-28	
		R. ALANI et al., An Updated Gas Source Focused Ion Beam Instrument for TEM Specimen Preparation, Mat. Res. Soc. Symp. Proc. Vol. 254, 1992 Materials Research Society, pgs. 65-78	
		Brochure, FB-2000A FOCUSED ION BEAM SYSTEM, Hitachi, pgs. 1-5	
		R. ALANI et al., An Updated Ion Polishing System for TEM Specimen Preparation of Materials, Mat. Res. Soc. Symp. Proc. Vol. 480, 1997 Materials Research Society, pgs. 263-292	
		Brochure, Model 645 PIMS Precision Ion Milling System, Gatan	
		L. BERTHOLD and E. LANGER, TEM-Cross Section Preparation Using Wire Shadowing	
		Internet document, Ion Milling with RES 100, BAL-TEC	
		Brochure, Model 691 Precision Ion Polishing System (PIPS), Gatan	
		Internet document, R. ALANI et al., Recent Advances in Broad Ion Beam Techniques: Instrumentation for SEM Specimen Preparation of Semiconductors, Cahners, Semiconductor International	

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